



**ELECTRONIC COPY**

LG795612282  
Report verification at igi.org



April 25, 2026

IGI Report Number **LG795612282**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **OVAL BRILLIANT**

Measurements **12.18 X 8.71 X 5.42 MM**

**GRADING RESULTS**

Carat Weight **3.63 CARATS**

Color Grade **E**

Clarity Grade **VVS 2**

April 25, 2026  
IGI Report Number **LG795612282**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **OVAL BRILLIANT**  
Measurements **12.18 X 8.71 X 5.42 MM**

**GRADING RESULTS**

Carat Weight **3.63 CARATS**

Color Grade **E**

Clarity Grade **VVS 2**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

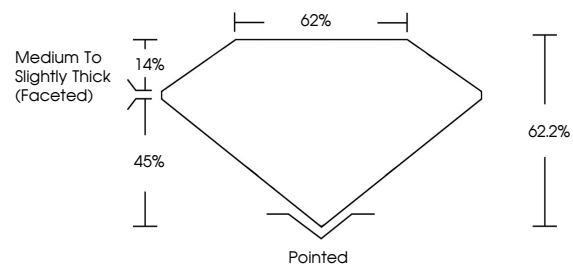
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG795612282**

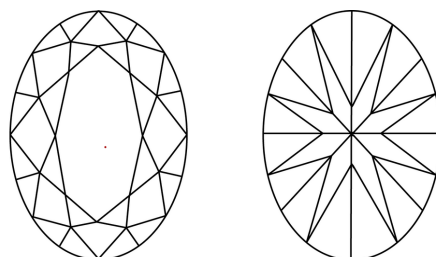
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

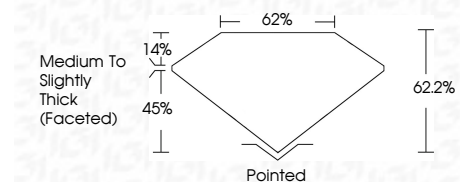
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG795612282**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa



**IGI**



April 25, 2026  
IGI Report No LG795612282  
**OVAL BRILLIANT**  
12.18 X 8.71 X 5.42 MM  
Carat Weight **3.63 CARATS**  
Color Grade **E**  
Clarity Grade **VVS 2**  
Depth **62.2%**  
Table **62%**  
Girdle **Medium to Slightly Thick (Faceted)**  
Culet **Pointed**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG795612282**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa